

<b>Notice of References Cited</b>	Application/Control No. 10/593,249	Applicant(s)/Patent Under Reexamination YAZAWA ET AL.	
	Examiner DANIEL BERNS	Art Unit 1736	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Mikawa et al., "Helical Etch Channels in Synthetic Quartz Crystals." 1998 IEEE Int'l Frequency Control Symposium, pp. 801-805 (1998, no month).
	V	Wilson, P., "Experimental investigation of etch put formation on Quartz sand grains." Geological Magazine 116 (6), pp. 477-482 (1979, no month).
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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